

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Hiroshi Naito et al.

Application No.: 10/584,666

Confirmation No.: 4975

Filed: May 29, 2007

Art Unit: 2858

For: MAGNETIC SENSOR AND
MANUFACTURING METHOD THEREFOR

Examiner: LeDinh, Bot L.

RESPONSE TO RESTRICTION REQUIREMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the restriction requirement set forth in the Office Action mailed January 5, 2010, applicant hereby elects Group II, Species III claims 2, 3, 5, 7, 9 and 11 without traverse, for initial examination on the merits.

Applicant reserves the right to file divisional applications to pursue non-elected claims 1,8,10, and 12-14.

Dated: March 5, 2010

Respectfully submitted,

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